

PTO-1449	Application No.	Agent(s)	
	09/746,822	Islam, et al.	
Information Disclosure Citation in an Application	Docket Number	Group Art Unit	Filing Date
	068069.0110		12/22/2000

U.S. PATENT DOCUMENTS

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HP	E	5,459,610	10/17/95	Bloom, et al.	359	572	05/20/93
HP	F	5,500,761	03/19/96	Goossen, et al.	359	290	01/27/94
HP	G	5,654,819	08/05/97	Goossen, et al.	359	291	01/07/95
HP	H	5,659,418	08/19/97	Yurke	359	290	02/05/96
HP	I	5,661,592	08/26/97	Bornstein, et al.	359	291	01/07/95
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HP	K	5,745,271	04/28/98	Ford, et al.	359	130	07/31/96
HP	L	5,751,469	05/12/98	Arney, et al.	359	291	02/01/96
HP	M	5,825,528	10/20/98	Goossen	359	291	12/26/95
HP	N	5,835,255	11/10/98	Miles	359	291	05/05/94
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HP	R C. Marxer, et al., "Megahertz Opto-Mechanical Modulator," Elsevier Science S.A., pp. 46-50	1996
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HP	D	5,943,155	08/24/99	Goossen	359	247	08/12/98
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HP	T	D. M. Burns, et al., "Micro-Electro-Mechanical Variable Blaze Gratings," IEEE 10th Annual International Workshop on Micro Mechanical Systems, pp. 385-391	1997
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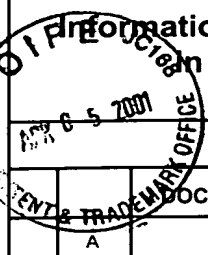

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